

U.S. PRO  
JC879 10/047818  
01/15/02

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10047818	FILING DATE 01/15/2002	CLASS 134	SUBCLASS 840	GAU 1746	EXAMINER Robert Moore
----------------------	---------------------------	--------------	-----------------	-------------	--------------------------

\*\*APPLICANTS: Nishimura Joichi; Ohtani Masami; Hashinoki Kenji; Shiga Masayoshi;  
Hashimoto Koji; 156 345,32 1763

\*\*CONTINUING DATA VERIFIED:

BEST AVAILABLE COPY

\*\* FOREIGN APPLICATIONS VERIFIED:

JAPAN P2001-010647 01/18/2001

JAPAN P2001-217882 07/18/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiner's initials	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO P/1250-217	
TITLE : Substrate processing apparatus			

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L(Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
Amount Due	Date Paid		Total Claims	Print Claim for O.G
ISSUE FEE		Primary Examiner	DRAWING	
TERMINAL	DISCLAIMER		Sheets Drwg.	Figs.Drwg.
PREPARED FOR ISSUE		Application Examiner		
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.				

FILED WITH:

DISK (CRF)

CD-ROM  
(Attached in pocket on right inside flap)